

Substitute Specification

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TITLE

METHOD FOR MANUFACTURING ELECTRON EMISSION ELEMENT, ELECTRON SOURCE, AND IMAGE FORMING APPARATUS

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This application is a division of U.S. Patent Application No. 09/848,360, filed May 4, 2001, which is a division of U.S. Patent Application No. 09/248,102, filed February 11, 1999, now U.S. Patent 6,267,636.

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BACKGROUND OF THE INVENTION

FIELD OF THE INVENTION

The present invention relates to a method for manufacturing an electron emission element, an electron source having a plurality of the electron emission elements arranged therein, and an image forming apparatus such as a display that is configured using the electron source.

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